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Bib Data Sheet

CONFIRMATION NO. 7107

SERIAL NUMBER 10/527,642	FILING OR 371(c) DATE 03/14/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 267410US26PCT
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APPLICANTS

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CONTINUING DATA ***

This application is a 371 of PCT/JP03/11971 09/19/2003

** FOREIGN APPLICATIONS *****

JAPAN 2002=273709 09/19/2002

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials			

ADDRESS

22850

TITLE

Method for forming insulating film on substrate, method for manufacturing semiconductor device and substrate-processing apparatus

FILING FEE RECEIVED 1710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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